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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

None. SSF

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 10-2002-0083527 12/24/2002 SSF

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <u>[Signature]</u> <u>SSF</u> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 2	INDEPENDENT CLAIMS 1
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## TITLE

Methods for forming capacitors and contact holes of semiconductor devices simultaneously

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